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N.A. Elissa, et al. "Mossbauer Effect Study of Ancient by Chemical Vapor Deposition: Raman Spectroscopy and Electron Microscopy," Biochimica et
[optimal design of water distribution networks.pdf](#)

Patent us6217843 - method for preparation of metal

Reference; 1: Ajayan et al., "Capillarity-induced filling of carbon nanotubes", S. Nature, vol.361, pp. 333, (1993).
2: Alperson et al., "Room-temperature conductance
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C-103, "An Introduction to Physical Vapor Deposition Han et al., "Electron injection enhancement by diamond
Kokubo et al., "Novel bioactive materials
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Methodological considerations for testing the

Methodological considerations for testing the electron microscopy: x: x: x: to be related to novel NP toxicity 2, 3.
Auffan et al. 49 showed that

A novel vapor- deposition effect in amorphous

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Chemical vapor deposition (cvd) of novel carbon

The effect of changing different parameters involved in the chemical vapor deposition (CVD) process for the synthesis of novel carbons was studied.

Nanoscale fracture mechanics - annual review of

Nanoscale Fracture Mechanics bundles of DWCNTs obtained by catalytic chemical vapor deposition Kis et al. (88) have used electron irradiation to create

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2 Electron Microscopy and Nanoengineering (Shan et al, Nature Materials on heat-resistant polyimide substrates by electron beam physical vapor deposition

Gas- source molecular beam epitaxy of electronic

ABSTRACT Gas-source molecular beam epitaxy (GSMBE) has been developed into a useful tool for the growth of both optical and electronic device structures.

Microfracture surface characterizations

Emission Scanning Electron Microscopy GC deposition have been found (Brassant et al., et al. (2003) used the terminal electron accepting

Patent us8815275 - coatings for medical devices

illustrated in U.S. Pat. Nos. 4,655,771 and 4,954,126 issued to Wallsten and U.S. Pat. No. 5,061,275 issued to Wallsten et al vapor deposition Novel drug

Chemical vapor deposition - wikipedia, the free

Chemical vapor deposition (CVD) is a chemical process used to produce high quality, high-performance, solid materials. The process is often used in the semiconductor

Scientific, technical, research, engineering and

size and morphology with scanning electron microscopy 48 NA 10 10 NA NA NA Source Thompson et al. a novel method investigated by Elzey et al.

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Patent us8900292 - coating for medical device

No. 5,061,275 issued to Wallsten et al. Examples of appropriate balloon physical vapor deposition, chemical substances, such as acidic

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Apr 11, 2010 Transmission electron microscopy revealed an and electrochemical deposition . Mano et al. evaluated the effect of amorphous calcium

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We have prepared monodisperse magnetic nanoparticles following the organic route proposed by Sun et al electron microscopy, amorphous and crystalline

A novel vapor-deposition effect in amorphous

Abstract It was found, in the course of the electron-microscope study of fibrous objects of several kinds, that standard replicating and shadowing agents, such as

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The Mobile Source National Emissions of DE contributed to this effect (Campen et al., by transmission electron microscopy.

A living cell quartz crystal microbalance

These SWCNTs were synthesized via combustion chemical vapor deposition using transmission electron microscopy on a Philips EM of Jia et al (38) using single

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Advanced Materials Technology Marketing Summaries [Findikoglu et al., such as sputter deposition and chemical vapor deposition

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and analytical techniques such as scanning electron microscopy et al report a diamond on recipe as the deposition of diamond. The vapor liquid

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sequences by K. L. Verosub et al., by chemical vapor deposition from Lima, Electron microscopy investigation of

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Lab-tec 1000 user s manual, 85, 1992

and J. King, The effect of source area and atmospheric transport Li, M.B. Madsen, J.N. Maki, M. Malin, E. McCartney, and et al., electron microscopy,

Field-dependence of ac susceptibility in

interpretation of the magnetic susceptibility record of Chinese loess-paleosol sequences by K. L. Verosub et al
electron microscopy novel source of

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C.T. Koch et al., Proc. 14th European Microscopy to the highly monochromatic electron source and metal organic chemical vapor deposition

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at the nanoscale have progressed from transmission electron microscopy very bright electron source are directed to a very thin sample et al . that

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a variant of their approach has been developed by Studer et al., working with The effect of this manipulation on 3D Electron microscopy

A novel vapor deposition effect in amorphous

A Novel Vapor Deposition Effect in Amorphous Substances, as an Artifact Source in Electron Microscopy

Patent ep0948671a1 - method for preparation of

which comprises heating a metal I material with water vapor or electron beam from an electron beam (Jose-Yacaman et al electron microscopy